

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicants: | Yoshiaki Mori, et al. | Art Unit: | 1756 |
| Serial No.: | 10/026,286 | Examiner: | Daborah Chacko Davis |
| Filed: | December 20, 2001 | Confirmation No.: | 1796 |
| Title: | Pattern Forming Method and Apparatus Used for Semiconductor Device, Electric Circuit, Display Module, and Light Emitting Device | | |

RESPONSE D

Sir:

In response to the Office Action dated May 11, 2006 (Paper No./Mail Date 0503), please amend the above-identified application as follows: